

FORM PTO-1449 (Modified) INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket No. 005C134US9	Application Number 10/675,606
	Applicant DENATALE et al.	
	Filing Date September 29, 2003	Group Art Unit

## U.S. PATENT DOCUMENTS

Examiner Initials	Document Number							Date	Name	Class	Subclass	Filing Date If Appropriate
<i>AL</i>	5	5	7	8	9	7	6	11/1996	YAO	333	262	
<i>AL</i>	5	8	8	0	9	2	1	03/1999	THAM et al.	361	233	
<i>AL</i>	5	9	5	9	5	1	6	09/1999	CHANG et al.	334	14	
<i>AL</i>	6	2	8	1	8	3	8	08/2001	HONG	342	371	
<i>AL</i>	6	5	3	8	6	0	3	03/2003	CHEN et al.	342	372	7/21/2000

## FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>AL</i>	1	"HIGH ISOLATION CPW MEMS SHUNT SWITCHES PART 2: DESIGN", IEEE TRANSACTIONS ON MICROWAVE THEORY AND TECHNIQUES, DECEMBER 1999, Muldavin et al., p. 1-4.
	2	"QUICK PROTOTYPING OF FLIP CHIP ASSEMBLY WITH MEMS", Irwin, et al., 1998, NSF CENTER FOR ADVANCED MANUFACTURING AND PACKAGING OF MICROWAVE, OPTICAL AND DIGITAL ELECTRONICS, DEPT OF MECHANICAL ENGINEERING UNIVERSITY OF COLORADO, BOULDER, CO., 8 pages.
	3	"FLIP-CHIP ASSEMBLY FOR SI-BASED RF MEMS", PROCEEDINGS OF THE 12th IEEE INTERNATIONAL CONF. ON MICROELECTROMECHANICAL SYSTEMS (MEMS 99), JAN. 1999, pp 273-278.
Examiner <b>BENNY T. LEE</b> PRIMARY EXAMINER		Date Considered <i>15 Oct 2004</i>
EXAMINER: Initial if reference considered. Whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and then ignored. Include copy of this form with next communication to applicant.		